

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Masamichi NAKASHIBA et al. : Docket No. 2000-0722  
Serial No. 09/589,388 : Group Art Unit 3723  
Filed June 8, 2000  
APPARATUS FOR AND METHOD FOR  
POLISHING WORKPIECE



THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

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AMENDMENT IN REISSUE

Assistant Commissioner for Patents,  
Washington, D.C.

Sir:

Prior to initial examination of the above-referenced reissue  
application, kindly amend the application as follows:

IN THE CLAIMS:

Please add the following new claims:

*Sub F3 18*  
*a*  
~~38. A method of polishing a surface of a workpiece, the  
method comprising:  
holding a workpiece with a top ring;  
applying a first polishing pressure to a central portion  
of the workpiece;  
applying a second polishing pressure to an outer  
circumferential portion of the workpiece, wherein the first  
polishing pressure is different than the second polishing pressure,  
and the first and second polishing pressures are independently  
adjustable; and  
pressing a presser ring against a polishing surface.~~

10/12/2000 SSITHIB1 00000004 09589388

01 FC:103  
02 FC:102

270.00 OP  
640.00 OP

A.